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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Keshner, M.

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EXAMINER: Bret P. Chen

FILED: July 11, 2003

ART UNIT: 1762

TITLE: ROLL-VORTEX PLASMA CHEMICAL VAPOR DEPOSITION SYSTEM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Weiss, Moy & Harris, P.C.
4204 N. Brown Avenue
Scottsdale, AZ 85251-3989

March 30, 2007

I hereby certify that on the 30th day of March, 2007, this correspondence is being sent via facsimile to Examiner Bret P. Chen in Art Group 1762 at (571) 273-8300.

Jeffrey Weiss

AMENDMENT

Dear Sir:

This Amendment is in response to the January 11, 2007 Final Office Action concerning the above-identified application. Amendments to the Claims begin on page 2, and the Remarks begin on page 8 of the Amendment.

Please amend the subject patent application as follows: